

Notice of References Cited

Application/Control No.

10/532,757

Applicant(s)/Patent Under

Reexamination

JACKSON ET AL.

Examiner

STEVEN KIM

Art Unit

3685

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U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-6,256,773 B1	07-2001	Bowman-Amuah, Michel K.	717/121
*	B US-2001/0044781 A1	11-2001	Shutes, Christina S.	705/59
*	C US-2002/0129221 A1	09-2002	Borgia et al.	712/1
*	D US-2003/0229581 A1	12-2003	Green et al.	705/38
*	E US-6,735,701 B1	05-2004	Jacobson, Andrea M.	726/1
*	F US-2005/0071174 A1	03-2005	Leibowitz et al.	705/001
*	G US-6,912,502 B1	06-2005	Buddle et al.	705/1
*	H US-7,003,560 B1	02-2006	Mullen et al.	709/223
*	I US-2006/0293942 A1	12-2006	Chaddha et al.	705/008
*	J US-7,197,466 B1	03-2007	Peterson et al.	705/1
*	K US-7,430,590 B1	09-2008	Rive et al.	709/220
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
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P					
Q					
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S					
T					

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